Water-based and Biocompatible 2D Crystal Inks for All-Inkjet Printed Heterostructures

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Inkjet printing is an attractive fabrication technique as it allows for production of large-area, low-cost and flexible electronics on a wide range of substrates [1-2].

The advent of 2D materials, with their ground breaking properties, show promise in this regard: graphene inks can be easily produced by liquid-phase exfoliation in organic solvents such as N-methylpyrrolidone (NMP) [3]. Due to the physical properties of NMP, such inks are directly suitable for inkjet printing and have been already used to fabricate all-inkjet printed in-plane devices [4,5].

Water is very attractive being a low-cost, abundant, non-toxic solvent with a relatively low boiling point. However, unlike NMP, water does not have the physical properties for either liquid-phase exfoliation or inkjet printing. Hence, water-based inks need to be carefully formulated [6,7].

Here we show a simple method to produce highly concentrated (up to 8 mg/mL), stable and inkjet printable graphene dispersions in water [8]. The method has also been successfully extended to other 2D materials. The inks can be inkjet printed on a wide range of substrates (glass, plastic, paper, silicon, etc.) and are suitable for fabrication of both planar and vertical devices [8]. In particular, we show for the first time an array of 100 heterostructure-based devices entirely made by inkjet printing [8].

Preliminary in vitro dose-escalation cytotoxicity tests also demonstrated the biocompatibility of the inks, extending their possible use to biomedical applications [8].

References

- H. Sirringhaus, et. al., Science, 290, 2123-2126, (2000).
- Inkjet technology for digital fabrication, Ian M. Hutchings, Graham D. Martin, 2012
- [3] Y. Hernandez, et. al., Nat. Nano., 9, 563-568, (2008).
- [4] D. J. Finn, et. al., J. Mat. Chem. C, 5, 925-932, (2014).
- [5] F. Torrisi, et. al., ACS Nano, 6, 2992-3006 (2012).
- [6] H. Yang, et. al., 2D Materials, 1, 01102 (2014).
- [7] A. Schlierf, et. al., Nanoscale, 5, 4205-4216 (2013).
- [8] D. McManus, et. al., Nat. Nano., Accepted.